

IFW

PATENT  
Docket No. 20067/OPP031054US

IN THE UNITED STATES PATENT  
AND TRADEMARK OFFICE

Applicant(s):

**Date-Gun Lee**

U.S. Serial No.: 10/734,808

For: "Methods to Fabricate a  
Semiconductor Device"

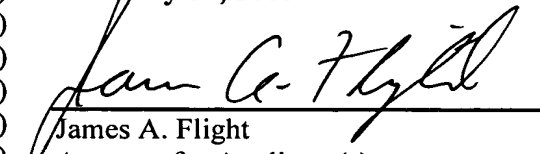
Filed: December 12, 2003

Group Art Unit: 2812

Examiner: Not Yet Assigned

) I hereby certify that this paper and the  
) documents referred to as enclosed  
) therewith are being deposited with the  
) United States Postal Service as first  
) class mail, postage prepaid, in an  
) envelope addressed to Commissioner  
) for Patents, P.O. Box 1450,  
) Alexandria, Virginia 22313-1450 on  
) this date:

) **February 14, 2005**

)   
) **James A. Flight**  
) Attorney for Applicant(s)  
) Registration No. 37,622

**STATUS LETTER**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

Kindly advise when an Office action can be expected in the above-referenced  
matter.

Respectfully submitted,

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**February 14, 2005**

By:

  
**James A. Flight**  
Registration No.: 37,622